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Applicant
Jang et al.

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Unknown

INFORMATION DISCLOSURE STATEMENT
(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

*EXAMINER INITIALS	DOCUMENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
BK	U.S. 6,500,692	12-31-02	Methods of Making Thrench Photosensor for a CMOS Imager	438	73	02-14-01
BK	U.S. 6,177,333	01-23-01	Method for Making a Thench Isolation for Semiconductor Devices	438	433	
BK	U.S. 6,372,603	04-16-02	Photodiode with Thightly-Controlled Junction Profile For CMOS Image Sensor with STI Process	438	424	07-07-00

FOREIGN PATENT DOCUMENTS

*Examiner Initials	Document Number	Publication Date	Country	Class	Subclass	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

EXAMINER

Brown Kebede

DATE CONSIDERED

9/29/2004

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.